

Notice of References Cited	Application/Control No. 09/804,158	Applicant(s)/Patent Under Reexamination KAWADA ET AL.	
	Examiner Kripa Sagar	Art Unit 1756	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,952,128	09-1999	Isao et al.	430/5
	C	US-5,955,223	09-1999	Mitsui et al.	430/5
	D	US-5,938,897	08-1999	Isao et al.	204/192.15
	E	US-5,942,356	08-1999	Mitsui et al.	430/5
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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	V	"Long-throw, low pressure sputtering technology for very large-scale integrated evices", N.Motegi et al. , J.Vac.Sci.Technol., B v13,(1995), pp1906-1909.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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